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	Applicant(s): Mutsumi YANO, et al.	
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U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
_____	AA					
_____	AB					
..	AC					
.	AD					

FOREIGN PATENT DOCUMENTS

	Document No.	Date	Country	Translation (Yes or No)
<u>PK</u>	AE 5-121275	05/18/93	Japan	Yes-Abstract/Discussed in the specification
<u>PK</u>	AF 11-312628	11/09/99	Japan	Yes-Abstract/Discussed in the specification
_____	AG			
_____	AH			
_____	AI			

OTHER DOCUMENTS

<u>DJ</u>	AJ	G.E. Thompson et al.; "The Migration of Fluoride Ions in Growing Anodic Oxide Films on Tantalum"; <i>Journal Electrochemical Society</i> ; Vol. 144; No. 2; pp. 418-423, February, 1997.
Examiner	<u>DJ</u>	Date Considered 6/16/04